

<b>Notice of References Cited</b>	Application/Control No. 10/700,499	Applicant(s)/Patent Under Reexamination TAI ET AL.	
	Examiner Dr. Kelechi C. Egwim	Art Unit 1713	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,395,358	05-2002	Tai et al.	428/36.7
*	B	US-5,972,447	10-1999	Hata et al.	428/35.7
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	JP 63264656 A	11-1988	Japan	NEGI et al.	
*	O	JP 01204736 A	08-1989	Japan	NEGI et al.	
*	P	JP 63230757 A	09-1988	Japan	NEGI et al.	
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.